

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. TOMIHARA

Serial No. 09/961,368

Group Art Unit: 2829

Filed: September 25, 2001

Examiner: E. Pert

For: A METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE HAVING
FLEXIBLE WIRING SUBSTRATE (As Amended)

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 4, 2002,
please amend the above-identified application as follows. A
Petition and fee for a one-month Extension of Time accompanies
this response.